



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicants : Carlo Waldried et al.  
Serial No. : 10/627,894  
Filed : July 24, 2003  
Title : FLUORINE-FREE PLASMA CURING PROCESS FOR POROUS LOW-K  
MATERIALS  
Docket : AXD 0001 I3/31126.3

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Attorney - Brian L. Smiler Reg. No. 46,458

Sir:

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UNDER 37 CFR §§ 1.56, 1.97, AND 1.98

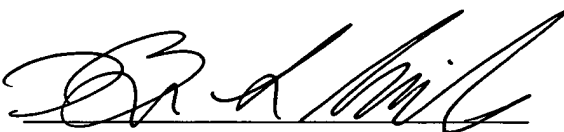
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This Information Disclosure Statement is being filed within the period set forth in 37 CFR §1.97(b) because it is believed to be filed before the mailing date of a first office action on the merits.

Serial No. 10/627,894  
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The Office has waived the requirement pursuant to 37 CFR 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 USC § 371 after June 30, 2003. Therefore, no copies of each cited U.S. patent and each cited U.S. patent application publication are enclosed, but the cited U.S. patents and the cited U.S. patent application publications are listed on PTO/SB/08A and PTO/SB/08B.

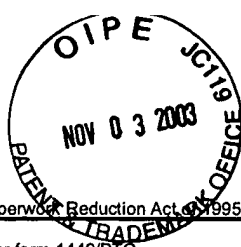
Respectfully submitted,  
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STATEMENT BY APPLICANT**

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Application Number	10/627,894
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First Named Inventor	Carlo Waldfried
Art Unit	
Examiner Name	
Attorney Docket Number	AXD 0001 I3/31126.3

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**U. S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US- 3,615,272	10/26/1971	Collins et al.	
		US- 4,636,440	01/13/1987	Sivananda S. Jada	
		US- 4,749,631	06/07/1988	Haluska et al.	
		US- 4,756,977	07/12/1988	Haluska et al.	
		US- 4,808,653	02/28/1989	Haluska et al.	
		US- 4,822,697	04/18/1989	Haluska et al.	
		US- 4,842,888	06/27/1989	Haluska et al.	
		US- 4,847,162	07/11/1989	Haluska et al.	
		US- 4,999,397	03/12/1991	Weiss et al.	
		US- 5,008,320	04/16/1991	Haluska et al.	
		US- 5,010,159	04/23/1991	Bank et al.	
		US- 5,063,267	11/05/1991	Hanneman et al.	
		US- 5,116,637	05/26/1992	Baney et al.	
		US- 5,210,160	05/11/1993	Saive et al.	
		US- 5,234,556	08/10/1993	Oishi et al.	
		US- 5,262,201	11/16/1993	Chandra et al.	
		US- 5,290,394	03/01/1994	Tokuhito Sasaki	
		US- 5,416,190	05/16/1995	Mine et al.	
		US- 5,523,163	06/04/1996	Balance et al.	

**FOREIGN PATENT DOCUMENTS**

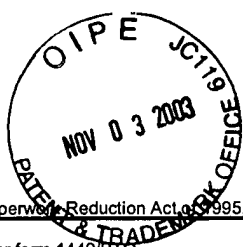
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
		JP 60-086017A	05/15/1985	Fujitsu Ltd.		
		EP 1189267	03/20/2002	Ulvac, Inc.		
		EP 1037275	09/20/2000	Canon Sales Co. Inc.		
		WO 0170628	09/27/2001	Dow Corning/Axcelis		

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Sheet 2 of 3

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		Number-Kind Code <sup>2</sup> (if known)			
		US- 5,547,703	08/20/1996	Camilletti et al.	
		US- 5,618,878	04/08/1997	Syktich et al.	
		US- 5,853,808	12/29/1998	Arkles et al.	
		US- 5,935,646	08/10/1999	Raman et al.	
		US- 5,961,851	10/05/1999	Kamarehi et al.	
		US- 6,054,206	04/25/2000	Mountsier	
		US- 6,080,526	06/27/2000	Yang et al.	
		US- 6,143,360	11/07/2000	Zhong	
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		US- 6,231,989 B1	05/15/2001	Chung et al.	
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		US- 2002/0136910 A1	09/26/2002	Harker	
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		US-			
		US-			

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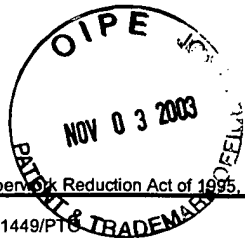
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Sheet 3 of 3

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		GLASSER ET AL., EFFECT OF THE H2O/TEOS RATIO UPON THE PREPARATION AND NITRIDATION OF SILICA SOL/GEL FILMS, Journal of Non-Crystalline Solids, 1984, 13pgs., Vol. 63, Elsevier Science Publishers B.V., North-Holland, Amsterdam	
		HAN Q. ET AL., "Ultra Low-K Porous Silicon Dioxide Films from A Plasma Process", Proceedings of the IEEE, International Interconnect Technology Conference, 4 June 2001, pgs. 171-173	
		KIM J-J ET AL., "The Effects of Plasma Treatment on SiO2 Aerogel Film Using Various Reactive (O2, H2, N2) and Non-Reactive (He, Ar) Gases", Thin Solid Films, Elsevier-Sequoia S.A. Lausanne, CH, Vol. 377-378, 1 December 2000, pgs. 525-529	
		Abstract for JP 59-178749A to Takeda (Fujitsu), 10/11/1984	
		Abstract for JP 63-107122A to Fukuyama et al. (Fujitsu) 05/12/1988	

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